

Program at-a-glance

Monday 9/19		Tuesday 9/20			Wednesday 9/21			Thursday 9/22			Friday 9/23		
C 03	C 04	Plenary Hall C01	Hall 1 B08-B09	Hall 2 B05-B07	Plenary Hall C01	Hall 1 B08-B09	Hall 2 B05-B07	Plenary Hall C01	Hall 1 B08-B09	Hall 2 B05-B07	Plenary Hall C01	Hall 1 B08-B09	Hall 2 B05-B07
10:00 - 13:30		8:30 - 9:00			8:30 - 9:10			9:00 - 9:40			8:30 - 10:20		
Short Course I: Fine Beam Induced Processing Hans W.P. Koops	Short Course IV: Optical and X-ray lithography for MEMS applications Jost Goettert	Welcome address, MNE Fellow Award Ceremony			Plenary: Andreas Tünnermann Micro- and nanostructures for multichannel imaging - small lenses go big			Plenary: C. Grant Willson The Race to Higher Resolution: It's not over yet!			LIFE MICROFLUIDICS 2	MEMS METROLOGY	PHOT PLASMONICS
13:30 - 17:00		Plenary: Luc van den hove Semiconductors: core of a sustainable amazing world			Plenary: 9:10 - 9:50			9:40 - 10:20			10:20 - 10:50		
Short Course II: Lithography Modelling: Optical/EUV projection and selected other techniques Andreas Erdmann	Short Course III: Nano Imprint Lithography Hella-Christin Scheer	Plenary: Hiroyuki Fujita MEMS/NEMS for Nano and Biotechnologies			Plenary: Michelle Simmons Atomically Precise Silicon Devices in All Three Dimensions			Plenary: Viola Vogel How cells exploit the nanomechanics of proteins			Coffee break		
19:00 - 21:00		10:20 - 10:50			9:50 - 10:20			10:20 - 10:50			10:50 - 13:00		
Welcome Reception		Coffee break			Coffee break			Coffee break			NANO NOVEL FABRICATION 2		
		10:50 - 12:50			10:20 - 12:30			10:50 - 13:00			LITH BEAMS 2		
		LITH IMPRINT 1	NANO NANO-ELECTRONIC DEVICES	MEMS MEMS/NEMS 1	LITH IMPRINT 2	PHOT PHOTONICS & PHOTO-VOLTAICS	NANO NOVEL FABRICATION 1	MEMS PATTERN TRANSFER 2	LIFE LAB ON CHIP	LITH SELFASSEMBLY	LIFE BIOMEMS 2		
		12:50 - 14:20			12:30 - 14:00			13:00 - 14:10			THE END		
		Lunch			Lunch			Lunch					
		14:20 - 15:50			14:00 - 15:50			14:10 - 16:00					
MEMS MICROSYS 1	LITH BEAMS 1	LIFE MICRO-FLUIDICS 1	LIFE BIOMEMS 1			MEMS PATTERN TRANSFER 1	LITH SELFASSEMBLY	MEMS MICROSYS 2	LITH PHOTOLITHOGRAPHY	NANO CARBON MATERIALS			
		15:50 - 18:30			15:50 - 18:00			16:00 - 16:30					
		Poster Session 1 Posters with ODD numbers Levels A and C			Poster Session 2 Posters with EVEN numbers Levels A and C			16:30 - 18:20					
		18:30			18:30			LITH IMPRINT 3	LIFE CELL INTER-FACES	MEMS MEMS/NEMS 2			
		Conference Dinner			Conference Dinner								